

Docket: 8021-160 (SS-18118-US)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sun et al.

Examiner: Thanh V. Pham

Serial No.: 10/621,292

Group Art Unit: 2823

Filed: July 17, 2003

For: **METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING A
NICKEL SALICIDE PROCESS**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This paper is being filed in response to the Final Office Action dated April 3, 2007.

*OK to enter
TWP
06/08/2007*